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Attorney Docket No. CIT.PAU.01

1753

Patent
CIT.PAU.01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:
SCHERER ET.AL.

SERIAL NO. : 10/068,283

FILED: FEB. 5, 2002

FOR: DRY ETCHING AND MIRROR
DEPOSITION PROCESSES
FOR SILICONE ELASTOMER

Examiner: R. McDonald

Group Art Unit: 1753

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OCT 14 2003
TC 1700

AMENDMENT

Hon. Commissioner of Patents and Trademarks
Washington DC 20231

Sir:

In reply to the Office Action mailed June 30, 2003, please enter the following amendments and consider the following remarks.

Claims 1 – 20 were original in the application. Claims 2 – 13 have been indicated as allowable. Claim 1 has been amended. Claims 16 – 20 were withdrawn. Claims 21 – 25 are new. Therefore, claims 1 – 15 and 21 – 25 are submitted for examination on the merits in amended form.

A check for the appropriate fee for excess claims for a small entity is included.

The Office is also authorized to charge all fees under 37 CFR § 1.17, or all required extension of time fees or any deficit and credit any surplus in such fees to our deposit account #01-1960.

10/08/2003 TBESHAH1 00000048 10068283

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10/31/2003 ASPELL/MON 00000001 10068283
01 FC:2202
02 FC:2201
45.00 OP
81.00 OP
48.00 DA